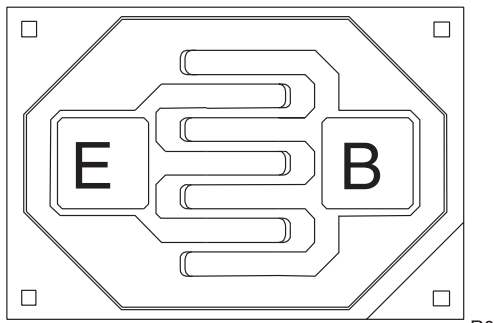


**PROCESS DETAILS**

|                          |                  |
|--------------------------|------------------|
| Process                  | EPITAXIAL PLANAR |
| Die Size                 | 13 x 17 MILS     |
| Die Thickness            | 9.0 MILS         |
| Base Bonding Pad Area    | 3.0 X 3.0 MILS   |
| Emitter Bonding Pad Area | 3.0 X 3.0 MILS   |
| Top Side Metalization    | Al - 30,000Å     |
| Back Side Metalization   | Au - 18,000Å     |

**GEOMETRY**



BACKSIDE COLLECTOR

**GROSS DIE PER 4 INCH WAFER**

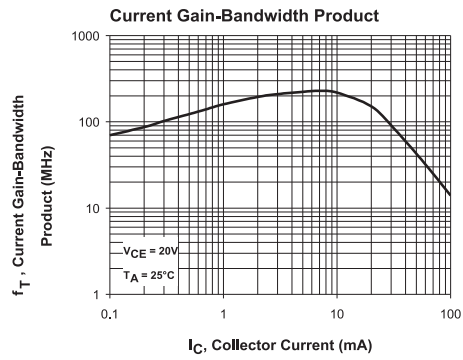
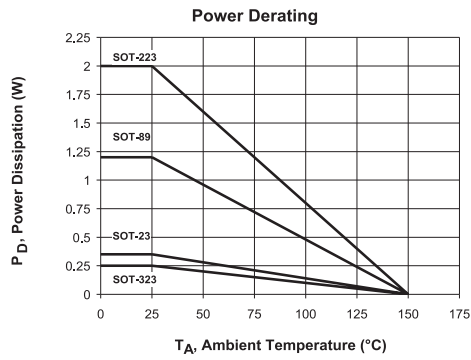
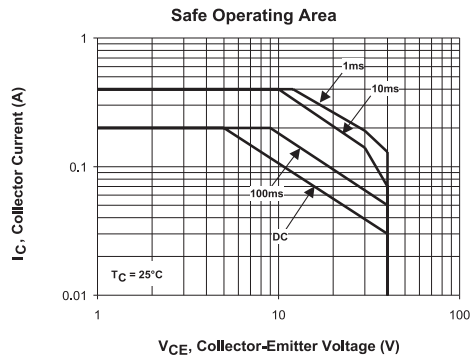
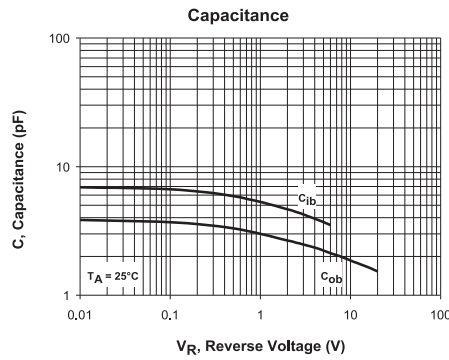
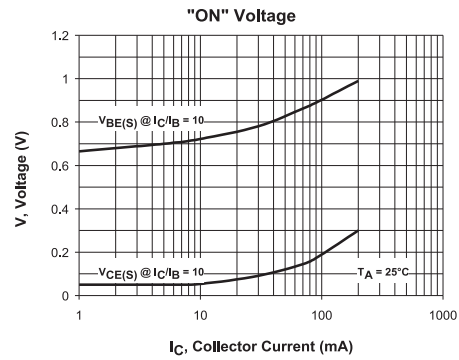
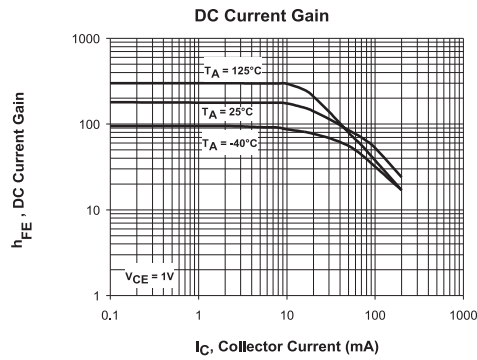
52,240

**PRINCIPAL DEVICE TYPES**

- 2N3904
- CMPT3904
- CMST3904
- CXT3904
- CZT3904

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